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APPLICANT  
Ming Michael Li

FILING DATE  
February 6, 2002

GROUP ART UNIT  
2825

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PNR JA	AA	5,182,232	01/26/93	Chhabra et al.	437	200	
PNR	AB	5,394,012	02/28/95	Kimura	257	739	
PNR	AC	5,418,188	05/23/95	Harper et al.	437	200	
PNR	AD	5,585,295	12/17/96	Wu	437	44	
PNR	AE	5,599,746	02/04/97	Lur et al.	437	200	
PNR	AF	5,767,013	06/16/98	Park et al.	438	622	
PNR	AG	5,877,063	03/02/99	Gilchrist	438	398	
PNR	AH	5,993,685	11/30/99	Currie et al.	252	79.1	
PNR JA	AI	6,074,926	06/13/00	Cathey et al.	438	398	
	AJ						

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AK					
	AL					
	AM					
	AN					
	AO					

**OTHER PRIOR ART** (Including Author, Title, Date, Pertinent Pages, Etc.)

PNR JA	AP	Chang, C.Y. and Sze, S.M., "ULSI Technology," 1996, The McGraw-Hill Companies, Inc., pp. 229, 395-397
PNR JA	AQ	Wolf, S., "Silicon Processing for the VLSI Era," Vol. 2 - Process Integration, 1990, Lattice Press, pp. 45, 354-357.
	AR	

EXAMINER

*Quito N. Roach*

DATE CONSIDERED

9/29/2004 3/30/05

\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).